

U.S. DEPARTMENT OF COMMERCE
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**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT**

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10191/4351

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Examiner
To be assigned

Art Unit
2877

Invention Title
INTERFEROMETRIC MEASURING SYSTEM

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I hereby certify that this correspondence is being electronically
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Date: March 11, 2008

Signature: /Tessa Ramos/

Tessa Ramos

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicant(s) hereby bring the following reference(s) to the attention of the Examiner. The reference(s) are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. The filing of this Information Disclosure Statement and the attached PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
3. Copies of each patent, publication or other information listed on the modified PTO Form No. 1449 are enclosed, except as otherwise specified.

Dated: March 11, 2008

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